

LASER MONITORING USING BOTH THE REFLECTED AND TRANSMITTED INTERFERENCE PATTERNS OF AN ETALON

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BACKGROUND

The present invention concerns signal test and measurement and pertains particularly to laser monitoring using both the reflected and transmitted interference patterns of an etalon.

When using devices that measure the wavelength or frequency of optical 10 signals, such as optical spectrum analyzers or wavelength meters, calibration is important to insure accurate measurements are taken. When performing calibration, calibration references are used to provide a set of accurate, known frequencies or wavelengths.

Fabry-Perot Etalons have been used as a calibration reference in order to 15 provide discreet reference points over a longer range of wavelengths than is typically available when using a gas absorption cell. See, for example, USPN 6,421,120 B1 issued on July 16, 2002 to Kenneth R. Wildnauer for EXTENDED WAVELENGTH CALIBRATION REFERENCE.

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SUMMARY OF THE INVENTION

In accordance with an embodiment of the present invention, a laser signal is monitored. The laser signal is forwarded to an etalon. Light transmitted through the etalon is detected. Light reflected from the etalon is detected. A ratio is calculated from the detected light transmitted through the etalon and the 25 light reflected from the etalon.

BRIEF DESCRIPTION OF THE DRAWINGS

Figure 1 is a block diagram illustrating laser wavelength monitoring using both the reflected and transmitted interference patterns of an etalon in 5 accordance with an embodiment of the present invention.

Figure 2 shows example plots of signal ratios for reflected and transmitted interference patterns of an etalon during laser wavelength monitoring in accordance with an embodiment of the present invention.

Figure 3 shows an example plot of the improved dynamic range of the 10 transmission peak when a ratio is used in accordance with an embodiment of the present invention.

Figure 4 is a block diagram illustrating laser wavelength monitoring using both the reflected and transmitted interference patterns of an etalon in accordance with another embodiment of the present invention.

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DETAILED DESCRIPTION OF EMBODIMENTS OF THE INVENTION

Figure 1 shows an etalon 23 being used to monitor a tunable laser 21. For example, etalon 23 is a Fabry-Perot etalon. A Fabry-Perot etalon includes two reflective surfaces with a transmission medium between the two reflective 20 surfaces. A detector 25 detects light transmitted through etalon 23. A detector 26 detects light reflected from etalon 23.

When etalon 23 is a low finesse Fabry-Perot etalon, the light detected by detector 25 and by detector 26 can look very much like a sine wave but with

poor fringe contrast. When etalon 23 is a high finesse Fabry-Perot etalon, the light detected by detector 25 and by detector 26 can have very sharp peaks or dips that provide discreet points for reference.

A monitor 27 uses a ratio of the reflected light detected by detector 26 and 5 the transmitted light detected by detector 26 to track the wavelength of tunable laser 21. The transmission peaks of etalon 23 become taller and more narrow when the transmitted signal detected by detector 25 is divided by the reflected signals detected by detector 26. The sharpened peaks can be used to lock or compare etalon 23 with another reference to provide absolute wavelength 10 measurements.

Dividing the reflected signal detected by detector 26 by the transmitted signal detected by detector 25 generates a sinusoidal signal that is ideal for tracking the relative wavelength of tunable laser 21. The sinusoidal signal provides good contrast for interpolating between peaks.

15 While etalon 23 can be a high finesse Fabry-Perot etalon or another type of etalon, there are advantages to using a low finesse Fabry-Perot. For example, low finesse Fabry-Perot etalons are generally less expensive than high finesse Fabry-Perot etalons since low finesse Fabry-Perot etalons are easier to align, generally require only one cavity and do not require extremely high reflectivity 20 coatings.

The transmitted signal ($P_t[\lambda]$) detected by detector 25 can be described as set out by Equation 1 below:

Equation 1

$$P_t[\lambda] = \frac{T}{1 + F \sin^2 \left[\frac{2\pi n d \cos(\theta)}{\lambda} \right]}$$

In Equation 1, $P_t[\lambda]$ represents detected power, T represents transmittance, F is the coefficient of finesse, n is the index of refraction inside the cavity of etalon 23, d is the cavity length, θ is the angle at which the incident beam passes through the cavity and λ is the wavelength.

The reflected signal ($P_r[\lambda]$) detected by detector 26 can be described as set out by Equation 2 below:

Equation 2

$$P_r[\lambda] = \frac{R F \sin^2 \left[\frac{2\pi n d \cos(\theta)}{\lambda} \right]}{1 + F \sin^2 \left[\frac{2\pi n d \cos(\theta)}{\lambda} \right]}$$

In Equation 2, $P_t[\lambda]$ represents detected power, R represents reflectance, F is the coefficient of finesse, n is the index of refraction inside the cavity of etalon 23, d is the cavity length, θ is the angle at which the incident beam passes through the cavity and λ is the wavelength.

Monitor 27 uses the ratio formed when the transmitted signal detected by detector 25 is divided by the reflected signals detected by detector 26 to lock or compare etalon 23 with another reference to provide absolute wavelength measurements. This ratio is shown in Equation 3 below:

Equation 3

$$\frac{P_t[\lambda]}{P_r[\lambda]} = \frac{T}{R} \frac{1}{FSin^2\left[\frac{2\pi ndCos(\theta)}{\lambda}\right]}$$

In Figure 2, waveform 33 gives an example plot of the ratio of Equation 3 where x-axis 32 represents wavelength in nanometers (nm) and y-axis 31 5 represents decibels (dB).

Monitor 27 uses the ratio formed when the reflected signals detected by detector 26 is divided by the transmitted signal detected by detector 25, for example, for interpolation when tracking the relative wavelength. This ratio is shown in Equation 4 below:

10 Equation 4

$$\frac{P_r[\lambda]}{P_t[\lambda]} = \frac{R}{T} FSin^2\left[\frac{2\pi ndCos(\theta)}{\lambda}\right]$$

In Figure 2, waveform 36 is an example plot of the ratio of Equation 4 where x-axis 34 represents wavelength in nanometers (nm) and y-axis 35 represents decibels (dB). For example, waveform 36 can be displayed by 15 monitor 27 on a display 28 (shown in Figure 1).

Figure 3 shows an example plot of the improved dynamic range of the transmission peak when a ratio is used. The plot represents the case where finesse (F) equals ten and the reflectance (R) equals the transmittance (T). In Figure 4, waveform 44 represents the ratio P_t/P_r . Waveform 43 represents P_t . 20 X-axis 41 represents ∂/π . Y-axis 35 represents decibels (dB).

The sharpened peaks can be used to lock or compare an etalon with

another reference to provide absolute wavelength measurements. This is illustrated by Figure 4. Figure 4 shows an etalon 13 being used to monitor a tunable laser 11. For example, etalon 13 is a Fabry-Perot etalon. A detector 15 detects light transmitted through etalon 13. A detector 16 detects light reflected 5 from etalon 13. A detector 14 detects light through gas absorption cell 12. Gas absorption cell 12 provides absorption lines in a particular part of the spectrum, overlapping at least a portion of the periodic response of etalon 13. For example gas absorption cell 12 is filled with acetylene, methane, hydrogen cyanide, carbon monoxide, hydrogen iodide, or water vapor. Gas absorption cell 12 acts 10 as a reference to provide absolute wavelength measurements.

A monitor 17 uses a ratio of the reflected light detected by detector 16 and the transmitted light detected by detector 15 to track the wavelength of tunable laser 11. The transmission peaks of etalon 13 become taller and more narrow when the transmitted signal detected by detector 15 is divided by the reflected 15 signals detected by detector 16. The sharpened peaks can be used to lock or compare etalon 13 with the signal detected by detector 14.

The foregoing discussion discloses and describes merely exemplary methods and embodiments of the present invention. As will be understood by those familiar with the art, the invention may be embodied in other specific 20 forms without departing from the spirit or essential characteristics thereof. Accordingly, the disclosure of the present invention is intended to be illustrative, but not limiting, of the scope of the invention, which is set forth in the following claims.